Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/767,765	OGAWA, HIDEHIKO	
Examiner	Art Unit	
Thomas D. Lee	2624	

	SEARCHED				
Class	Subclass	Date	Examiner		
358	1.15, 402, 440	12/8/2005	TDL		
379	100.01	12/8/2005	TDL		
379	100.08	12/8/2005	TDL		
379	100.13	12/8/2005	TDL		
379	100.17	12/8/2005	TDL		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		